

L Number	Hits	Search Text	DB	Time stamp
-	1	"20030094130" .pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/06/17 11:24
-	2	6013134.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/06/17 11:26
-	120	third near4 pump\$4 and semiconductor and (CVD or LPCVD or UHV\$1CVD)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/06/17 11:29
-	24	third near4 pump\$4 and semiconductor and (CVD or LPCVD or UHV\$1CVD) and single near3 (vessel or chamber or reactor)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/06/17 11:32
-	24	(CVD and (LPCVD or UHV\$1CVD)) same single near3 (vessel or chamber or reactor)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/06/17 11:40
-	8	(cryopump\$3 or cyro\$1pump\$3) near10 scroll	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/06/17 11:43
-	17	(root\$1 near2 blower) same (turbomolecular near3 pump) same (mechanical near2 pump)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/06/17 13:15
-	68	LPCVD same UHV	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/06/17 13:24
-	4	aicvd	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/06/17 13:24
-	1	20030070608.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/06/17 13:41
-	39	vacuum near5 chamber and vacuum near4 systems! near7 (third or multipl\$3 or several or second) and (CVD or chemical near2 vapor or epitax\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/06/17 13:51
-	9	vacuum near5 chamber near4 single and vacuum near4 systems! near7 (third or multipl\$3 or several or second) and (CVD or chemical near2 vapor or epitax\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/06/17 14:00
-	4	5298452.pn. or 5259918.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/06/17 14:00
-	276	117/90.cccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/06/17 16:09

